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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/717,571	11/21/2003	Koji Shigemura	1670.1020	9396
49455	7590 10/18/2005		EXAM	INER
STEIN, MCEWEN & BUI, LLP 1400 EYE STREET, NW SUITE 300 WASHINGTON, DC 20005			WALFORD, NATALIE K	
			ART UNIT	PAPER NUMBER
			2879	
	•		DATE MAILED: 10/18/200	5

Please find below and/or attached an Office communication concerning this application or proceeding.

		[] [] [] [] [] [] [] [] [] []			
	Application No.	Applicant(s)			
	10/717,571	SHIGEMURA, KOJI			
Office Action Summary	Examiner	Art Unit			
	Natalie K. Walford	2879			
The MAILING DATE of this communication Period for Reply	appears on the cover sheet with	th the correspondence address			
A SHORTENED STATUTORY PERIOD FOR REWHICHEVER IS LONGER, FROM THE MAILING Extensions of time may be available under the provisions of 37 CF after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by some Any reply received by the Office later than three months after the rearned patent term adjustment. See 37 CFR 1.704(b).	G DATE OF THIS COMMUNIC R 1.136(a). In no event, however, may a re n. eriod will apply and will expire SIX (6) MON tatute, cause the application to become AB	CATION. apply be timely filed THS from the mailing date of this communication. ANDONED (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on 2	21 November 2003.				
2a) ☐ This action is FINAL . 2b) ☑	This action is FINAL . 2b)⊠ This action is non-final.				
3) Since this application is in condition for all	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is				
closed in accordance with the practice und	ler <i>Ex parte Quayle</i> , 1935 C.D	. 11, 453 O.G. 213.			
Disposition of Claims					
4) Claim(s) 1-19 is/are pending in the applica	ition.				
4a) Of the above claim(s) is/are with	ndrawn from consideration.				
5) Claim(s) is/are allowed.					
6) Claim(s) is/are rejected.					
7) Claim(s) is/are objected to.					
8)⊠ Claim(s) <u>1-19</u> are subject to restriction and	d/or election requirement.				
Application Papers					
9)☐ The specification is objected to by the Exam	miner.				
10) The drawing(s) filed on is/are: a)	accepted or b) objected to □	by the Examiner.			
Applicant may not request that any objection to	the drawing(s) be held in abeyan	ce. See 37 CFR 1.85(a).			
Replacement drawing sheet(s) including the co					
11)☐ The oath or declaration is objected to by th	e Examiner. Note the attached	Office Action or form PTO-152.			
Priority under 35 U.S.C. § 119					
12) ☐ Acknowledgment is made of a claim for for a) ☐ All b) ☐ Some * c) ☐ None of:	eign priority under 35 U.S.C. §	119(a)-(d) or (f).			
 Certified copies of the priority document 					
2. Certified copies of the priority document					
3. Copies of the certified copies of the	•	received in this National Stage			
application from the International Bu * See the attached detailed Office action for a	, , , , , , , , , , , , , , , , , , , ,	received			
See the attached detailed Office action for a	anst of the certified copies not	received.			
Attachment(s)	_				
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) 		summary (PTO-413) s)/Mail Date			
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SI Paper No(s)/Mail Date		nformal Patent Application (PTO-152)			

Application/Control Number: 10/717,571

Art Unit: 2879

DETAILED ACTION

Election/Restrictions

Restriction to one of the following inventions is required under 35 U.S.C. 121:

- Claims 1-7, drawn to the deposition mask frame assembly, classified in class 118, subclass 720.
- II. Claims 8-13, drawn to a method of manufacturing a deposition mask frame assembly, classified in class 205, subclass 125.
- III. Claims 14-19, drawn to a method of manufacturing an organic EL device, classified in class 427, subclass 66.

The inventions are distinct, each from the other because of the following reasons:

The inventions are distinct if it can be shown that either: (1) the process as claimed can be practiced by another materially different apparatus or by hand, or (2) the apparatus as claimed can be used to practice another and materially different process. (MPEP § 806.05(e)). In this case, the apparatus as claimed can be used to practice another and

Inventions I and II or III are related as process and apparatus for its practice.

materially different process such as deposition of phosphorescent materials in cathode

ray tube faceplates.

Inventions II and III are related as subcombinations disclosed as usable together in a single combination. The subcombinations are distinct from each other if they are shown to be separately usable. In the instant case, invention II has separate utility such

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as for the electroplating deposition of electrode structures in liquid crystal displays. See MPEP § 806.05(d).

The inventions are distinct, each from the other because of the following reasons:

Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, and because of their recognized divergent subject matter, restriction for examination purposes as indicated is proper.

A telephone call was made to Michael Stein on September 28, 2005 to request an oral election to the above restriction requirement, but did not result in an election being made.

Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Natalie K. Walford whose telephone number is (571)-272-6012. The examiner can normally be reached on Monday-Friday, 8 AM - 4:30 PM. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nimesh Patel can be reached on (571)-272-2457. The fax phone number for the organization where this application or proceeding is assigned is (571)-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

nkw Walpra

MARICELI SANTIAGO PRIMARY EXAMINER